IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Ap	plication of:	
Takashi SHUT	O et al.	
Application No	.:	Group Art Unit: Not Yet Assigned
Filed: January	28, 2004	Examiner: Not Yet Assigned
For: METHO	DD OF MANUFACTURING CIRCUIT	BOARD
	INFORMATION DISC	LOSURE STATEMENT
Commissioner PO Box 1450 Alexandria, VA		
Sir:		
certain informa patent applicat	tion which the Examiner may consid	ovisions of 37 CFR § 1.56, there is hereby provided er material to the examination of the subject U.S. or make this information of record if it is deemed in.
1.	Enclosures accompanying this Information	nation Disclosure Statement are:
1a. 1b. 1c. 1d. 1e.	 Copies of IDS citations. An English language copy of sor a PCT International Search English language translation (or non-English language publications) Explanations of Relevancy of F 	complete or relevant portion(s)) attached to each
2.	In accordance with 37 CFR § 1.98, understood to be the relevance of e	a concise explanation of what is presently each non-English language publication is
2a.	"English-language version of the of relevance found by the forei	sh language publications were cited on the enclosed ne search report or action which indicates the degree gn office". (See MPEP 609, Minimum Requirements statement, Part A(3): Concise Explanation of

	English language translation (complete or relevant portion(s)) on-English language publication. ent 1(e), hereto.
material to patentability nor a re	information cited in this Statement is, or is considered to be, epresentation that a search has been made (other than part foreign application or a PCT International Search Report §§ 1.97(g) and (h).
	Respectfully submitted,
	STAAS & HALSEY LLP
Dated: January 28, 2004 1201 New York Ave., N.W., Suite 700 Washington, D.C. 20005 Telephone: (202) 434-1500 Facsimile: (202) 434-1501	By: Jandall Beckers Registration No. 30,358

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U.S. DEPARTMENT OF COMMERCE

ATTORNEY DOCKET NO. 1777.1001

FIRST NAMED INVENTOR

APPLICATION NO.

PATENT AND TRADEMARK OFFICE

LIST OF REFERENCES CITED BY APPLICANT

(Use several sheets if necessary)

Takashi SHUTO et al.

FILING DATE

January 28, 2004

GROUP ART UNIT

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NO.	DATE	NAME	CLASS	SUB- CLASS	FILING DATE
	AA	2003/162386 A1	8/2003	Ogawa et al.			
	AB						
	AC						
	AD						
	AE						
	AF			·			

FOREIGN PATENT DOCUMENTS

	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUB- CLASS	TRANSL YES	ATION NO
AG	6-216524	5/1994	Japan			Abs	
АН	2002-164467	7/2002	Japan			Abs	-
Al							
AJ							21.2.30
AK							
AL							

OTHER REFERENCES (INCLUDING AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.)

AM	
AN	
AO	

DATE CONSIDERED **EXAMINER**

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.